



IZW
AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tongbi Jiang et al.

§

Art Unit: 3729

Serial No.: 10/689,471

§

Examiner: Minh N. Trinh

Filed: October 20, 2003

§

Docket: MCT.0015C2US
97-0524.04US

For: A Method For Forming A Stencil
(As Amended)

§

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed November 8, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: December 8, 2004
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.
Cynthia L. Hayden

Cynthia L. Hayden